



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Toyokazu SAKATA

Appl. No: 09/736,140

Confirmation No: 8430

Filed: December 15, 2000

For: SEMICONDUCTOR DEVICE WITH
REDUCED INTERCONNECTION
CAPACITY (as amended)

Art Unit: 2811

Examiner: A. Williams

Atty. Docket No: 32011-168503

Customer No:



26694

PATENT TRADEMARK OFFICE

2811
#13
Suppl
105
Incl
4/17/03
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Supplemental Information Disclosure Statement

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

This is a Supplemental Information Disclosure Statement submitted in order to perfect the Information Disclosure Statement submitted on January 24, 2003.

Attached is a PTO-Form 1449 listing the documents cited in the enclosed Japanese Office Action (translation of pertinent information noted thereon), where the relevance is indicated. No further statement of relevance is required.

Pursuant to 37 C.F.R § 1.97(e)(1), on information and belief each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement.

In view of the above, no further translation or statement of relevance is required, and as all requirements of 37 C.F.R. § 1.97 and all official guide lines pertaining to Information

Application Serial No.: 09/736,140

Applicants: SAKATA

Disclosure Statements have been complied with, and it is therefore respectfully requested that the Examiner consider the documents and make them of record.

Respectfully submitted,

Date: March 19, 2003

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